

Docket No.: M4065.0369/P369 (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shane J. Trapp

Application No.: 09/752,685

Filed: January 3, 2001

Group Art Unit: 2813

Examiner: T. Pham

For: METHOD AND COMPOSITION FOR

PLASMA ETCHING OF A SELF-ALIGNED

CONTACT OPENING

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents Washington, DC 20231

. Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed November 2, 2001 (Paper No. 3), Applicant hereby provisionally elects, without traverse, Group I, claims 1-25 and 36-70 for continued examination.

Dated: November 27, 2001

Respectfully submitted,

Thomas J. D'Amico

Registration No.: 28,371

DICKSTEIN SHAPIRO MORIN &

OSHÍNSKY LLP

2101 L Street NW

Washington, DC 20037-1526

(202) 828-2232

Attorneys for Applicant

Capurela Conar

1374412 v1; TG\$401!.DOC